

<b>Notice of References Cited</b>	Application/Control No. 10/728,290		Applicant(s)/Patent Under Reexamination CLEMONS ET AL.	
	Examiner Igwe U. Anya		Art Unit 2825	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,451,626	09-2002	Lin, Charles W.C.	438/108
	B	US-6,433,425	08-2002	Sarkhel, Amit K.	257/737
	C	US-6,414,849	07-2002	Chiu, Anthony M.	361/760
	D	US-6,662,442	12-2003	Matsui et al.	29/852
	E	US-2004/0012934	01-2004	Jafari et al.	361/760
	F	US-2004/0012938	01-2004	Sylvester et al.	361/794
	G	US-5,829,125	11-1998	Fujimoto et al.	29/840
	H	US-6,133,626	10-2000	Hawke et al.	257/686
	I	US-6,140,707	10-2000	Plepys et al.	257/778
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2002016214 A	01-2002	Japan	HAYASHI, KAZUYOSHI	H01L 25/065
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.